

*“Multilayer MoS<sub>2</sub> growth by metal and metal oxide sulfurization”.* Heyne MH, Chiappe D, Meersschaut J, Nuytten T, Conard T, Bender H, Huyghebaert C, Radu IP, Caymax M, de Marneffe JF, Neyts EC, De Gendt S; Journal of materials chemistry C : materials for optical and electronic devices **4**, 1295 (2016). <http://doi.org/10.1039/c5tc04063a>